

Notice of References Cited	Application/Control No. 10/040,558	Applicant(s)/Patent Under Reexamination HSU, CHIUN-WEN	
	Examiner Richard Lee	Art Unit 2613	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-5,089,889 A	02-1992	Sugiyama, Kenji	375/240.12
	B	US-2003/0086496 A1	05-2003	Zhang et al.	375/240.16
	C	US-2002/0036705 A1	03-2002	Lee et al.	348/459
	D	US-5,280,350 A	01-1994	DeHaan et al.	348/699
	E	US-5,072,293	12-1991	De Haan et al.	348/699
	F	US-5,978,047 A	11-1999	May, Robert Edward	348/616
	G	US-4,890,160	12-1989	Thomas, Graham A.	348/699
	H	US-6,026,190 A	02-2000	Astle, Brian	382/232
	I	US-2002/0171759 A1	11-2002	Handjojo et al.	348/452
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

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